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LNAPW 512-439-7199

RECEIVED NO. 0531 P. 4
CENTRAL FAX CENTER PATENT

FEB 13 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED
DEPOSITION (IBAD)

App. No.: 10/602,467

Filed: June 23, 2003

Examiner: Brian K. Talbot

Group Art Unit: 1762

Customer No.: 34456

Confirmation No.: 2664

Atty. Dkt. No.: 1014-SP103

MS AMENDMENT
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed September 13, 2006, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>2-13-07</u> .	
<u>Debra J. Gilleooly</u> Typed or Printed Name	<u>Debra J. Gilleooly</u> Signature